



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. of:	Robert J. SMALL and Zhefei J. CHEN	Confirmation No:	1702
Serial No:	10/057,206	Group:	1755
Filed:	January 25, 2002	Examiner:	M. Marcheschi
Entitled:	Compositions for Chemical Mechanical Planarization of Noble-Metal-Featured Substrates, Associated Methods, and Substrates Produced by Such Methods		
		Atty Docket:	63254-5002-US

RESPONSE UNDER 37 C.F.R. §1.111

U.S. Patent and Trademark Office
Randolph Building
401 Dulany Street
Alexandria, Virginia 22314
MAIL STOP – AMENDMENT

Sir:

In response to the Office Action mailed on April 22, 2008, please consider the following amendments and remarks:

A list of the pending claims begins on page 2 of this Response; and
Remarks begin on page 10 of this response.